

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re DIVISIONAL Application of)
Hisashi OHTANI et al.)
Based On Serial No. 08/861,001) Art Unit: 2824
Which Was Filed: May 21, 1997) Examiner: M. Lebentritt
For: METHOD FOR MANUFACTURING)
A SEMICONDUCTOR DEVICE) Date: June 14, 2000

Stevens
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9-7-00

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

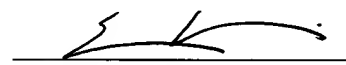
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 08/861,001 filed May 21, 1997, and its predecessor

application Serial No. 08/347,247.

Respectfully submitted,



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